

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Kazuya FUKUHARA)	Group Art Unit: 2624
)	
Application No.: 10/776,591)	Examiner: Mia M. THOMAS
)	
Filed: February 12, 2004)	
)	Confirmation No.: 3478
For: INSPECTION METHOD,)	
PROCESSOR AND METHOD FOR)	
MANUFACTURING A)	
SEMICONDUCTOR DEVICE)	

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AND RESPONSE TO OFFICE ACTION

In reply to the Office Action mailed February 3, 2009, the period for response having been extended to May 3, 2009, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper beginning on page 2.

Remarks follow the amendment sections of this paper beginning on page 9.